

PATENT APPLICATION  
Docket No. 9898-339

In re application of: Yoon-Jong Song, et al.  
Serial No.: 10/721,689 Art Unit: not yet assigned 2814  
Filed: November 24, 2003 Examiner: not yet assigned QUACH  
For: FERROELECTRIC MEMORY DEVICE USING VIA ETCH-STOP  
LAYER AND METHOD FOR MANUFACTURING THE SAME

INFORMATION DISCLOSURE CITATION  
FORM PTO-1449 (Modified)

U.S. PATENT DOCUMENTS

| Exam<br><u>Init</u> | Ref | Document<br><u>Number</u> | Issue<br><u>Date</u> | Name         | Class | Sub<br><u>Class</u> |
|---------------------|-----|---------------------------|----------------------|--------------|-------|---------------------|
| TE                  |     | 6,600,185                 | 7/2003               | Tani, et al. | 257   | 296                 |

Examiner: TEQUACH

Date Considered: 10/29/04